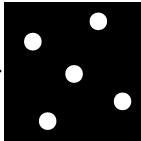
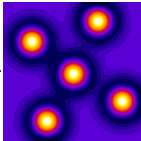
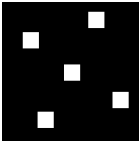


Optical model   Resist model



Mask pattern

Aerial image

Resist pattern